

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OZAKI, Takashi, et al.**

Group Art Unit: 1792

Serial No.: 10/528,137

Examiner: **MACARTHUR, Sylvia**

Filed: **December 12, 2005**

P.T.O. Confirmation No.: 2307

**FOR: SUBSTRATE PROCESSING APPARATUS AND METHOD FOR
MANUFACTURING A SEMICONDUCTOR DEVICE**

REQUEST FOR STATUS

Assistant Commissioner for Patents
Washington, D.C. 20231

October 15, 2010

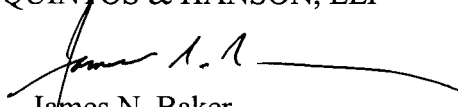
Sir:

The undersigned agent requests the status of the above-identified application.

A Request for Continued Examination was filed on March 9, 2010 in the U.S. Patent and
Trademark Office and to date no Office Action has been received.

Respectfully submitted,

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